


<b>Search Notes</b>  	<b>Application/Control No.</b>  10784170	<b>Applicant(s)/Patent Under Reexamination</b>  BACK, DAE-WHAN
	<b>Examiner</b>  Ryan C. Kavleski	<b>Art Unit</b>  2419

SEARCHED			
Class	Subclass	Date	Examiner
370	351, 216, 431, 248, 254	12/9/08	RK
ABOVE	UPDATED	4/8/09	RK

SEARCH NOTES		
Search Notes	Date	Examiner
EAST Based Search	12/8/08 (updated on 4/8/09)	RK
PLUS Based EAST Search	12/9/08 (updated on 4/9/09)	RK

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner

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